Docket No.: 061282-0055 PATENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer Number: 53080 In re Application of

Takeshi KOBAYASHI, et al. Confirmation Number: 4950

Group Art Unit: 2893 Application No.: 10/757,388

Examiner: Dilinh P. Nguyen Filed: January 15, 2004

LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR DEVICE For:

USING LEAD FRAME AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

## REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated October 6, 2010.

In reviewing the file, it is noted that we have not received an acknowledgement of the Information Disclosure Statement and cited art filed June 2, 2005. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement.

Applicants hereby respectfully request that:

- the acknowledged PTO-1449 be furnished to Applicant; and (1)
- the record be clarified to confirm that the cited art has been considered and made of **(2)** record.

Respectfully submitted,

WILL & EMERY LLP

Michael E. Fogarty

Registration No. 36,139

Please recognize our Customer No. 53080 as

ur correspondence address.

600 13th Street, N.W. Washington, DC 20005-3096

Phone: 202.756.8000 MEF/alb Facsimile: 202.756.8087

Date: November 3, 2009 WDC99 1788564-1.061282.0055

10/757,388 ss Mail No.	☐ Reply Brief	JUN 0 2 2005 52	AHumphries  AHumphries  THE DATE STAMPED.
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Applicant: Title:	Date Sent:		Check for Charles

Docket No.: 061282-0055 PATENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Takeshi KOBAYASHI, et al. : Confirmation Number: CNF NO. 4950

Application No.: 10/757,388 : Group Art Unit: 2818

Filed: January 15, 2004 : Examiner: Dilinh P. Nguyen

For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR

DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING

SEMICONDUCTOR DEVICE

## INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

# 10/757,388

foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty Registration No. *B*6,139

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Facsimile: 202.756.8087 **Date: June 2, 2005** 

Please recognize our Customer No. 20277 as our correspondence address.